| Notice of Allowability | Application No. | Applicant(s) | |
|--|-----------------------------|---|-------|
| | 09/966,046 | MAUTZ ET AL. | |
| | Examiner | Art Unit | |
| | David S Blum | 2813 | |
| The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. | | | |
| This communication is responsive to 11/07/03. The allowed claim(s) is/are 10,32,33 and 37. The drawings filed on 28 September 2001 are accepted by the Examiner. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) | | | |
| A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No (b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner. (c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d). | | | |
| 9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. | | | |
| Attachm nt(s) | | | |
| 1⊠ Notice of References Cited (PTO-892) 2☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08) Paper No | 6⊠ Interview Sui | ormal Patent Application (PTO- mmary (PTO-413), Paper No. <u>2</u> mendment/Comment | · · |
| 4☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material | 8⊠ Examiner's S 9⊡ Other | statement of Reasons for Allow | /ance |

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U.S. Patent and Trademark Office

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This action is in response to Amendment D, filed 11/07/03

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Michael J. Balconi-Lamica on 01/08/03.

The application has been amended as follows:

Replace claim 10 with amended claim 10.

Claim 10. A method of providing on a semiconductor wafer at least one region carrying information for identification of the semiconductor wafer, comprising:

providing a semiconductor wafer; and providing the at least one region with magnetic means, wherein the magnetic means are provided by ion implantation of magnetic ions.

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Reasons for Allowance

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2. Claims 10, 32-33, and 37 are allowed.

3. The following is an examiner's statement of reasons for allowance:

Claim 10 limits the formation of a device to having an identification region that is formed of magnetic means by ion implantation. This limitation, in combination with the other limitations of claim 10 is not taught or suggested by the prior art of record. The closest prior art, Katsuyuki (JP 58-169149) forms the identification magnetic means by deposition on the substrate but does not teach or suggest implanting the magnetic means into the substrate. Oishi (US006004405A), Yano (US006268641B1), and Huang (US006312876B1) make optical marks on the surface but do not suggest implantation into the substrate to form a magnetic means. Awschalom (US006307241B1) implants magnetic ions in a semiconductor wafer for memory but does not teach or suggest a method for using this implantation to identify the wafer.

Claims 32-33 and 37 are allowed as being dependent upon allowed claim 10.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to David S. Blum whose telephone number is (703)-306-9168 (after approximately 02/05/04 (7571-272-1687) and e-mail address is

David.blum@USPTO.gov .

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr., can be reached at (703)-308-4940. Our facsimile number all patent correspondence to be entered into an application is (703) 872-9306. The facsimile number for customer service is (703)-872-9317. Our receptionist's number is (703)-308-0956.

David S. Blum

January 8, 2004

ERIK J. KIELIN
PRIMARY EXAMINER

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